

Ripple-to-dome transition: The growth evolution of Ge on vicinal Si(1 1 10) surface

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We present a detailed scanning tunneling microscopy study which describes the morphological transition from ripple-to-dome islands during the growth of Ge on the vicinal Si(1 1 10) surface. Our experimental results show that the shape evolution of Ge islands on this surface is markedly different from that on the flat Si(001) substrate and is accomplished by agglomeration and coalescence of several ripples. By using published data of surface energy and finite-element analysis, we provide a meaningful explanation of our experimental observations.

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The heteroepitaxial growth of Ge and SiGe islands on vicinal Si(001) substrates has attracted wide interest as a model system for exploiting self-organized nanoscale texturing on surfaces.¹⁻⁴ Although the main mechanisms involved in Ge growth on the flat Si(001) have been elucidated,⁵⁻⁷ the vicinal systems exhibit many remarkable features which are still only partially understood. For example, it is well known that three-dimensional (3D) islands grown on the flat Si(001) surface show a bimodal behavior with shallow {105}-faceted pyramids at small volumes and steeper multifaceted domes at larger sizes.^{8,9} The pyramid-to-dome transition is driven by an abrupt change in chemical potential at a certain critical volume, corresponding to the crossover between the energy per atom of a dome and a corresponding energy per atom for a pyramid.⁹ During this morphological transition, a single Ge pyramid progressively converts to dome by step bunching at the island apex which generates new steeper facets.¹⁰ By contrast, a recent experimental study of Ge growth as a function of substrate vicinality¹¹ revealed that on the Si(1 1 10) surface {(001) substrate misoriented $\approx 8^\circ$ toward the [110] direction} pyramidal nanosized islands transform into elongated nanoripples¹² which are prisms of triangular cross section bounded by two adjacent {105} facets.¹⁴⁻¹⁶ Hitherto, the detailed pathway which leads to dome formation from ripplelike islands was unknown. Here, we report a systematic scanning tunneling microscopy (STM) study which describes this morphological transition. Our results show that the shape evolution of Ge islands on this surface differs markedly from that on the flat (001) surface and is accomplished by agglomeration and coalescence of several ripples. We corroborate our analysis with a realistic calculation of the formation energy of multifaceted islands on the 8° -miscut Si(001) surface, in comparison with the flat case. By combining experimental observations and theoretical results, we extend the thermodynamic model for the formation of multifaceted islands on Si(001) to include the unconventional features of the growth on vicinal surfaces.

Experiments were carried out in an ultrahigh-vacuum chamber ($p < 3 \times 10^{-11}$ torr) equipped with a variable-temperature scanning tunneling microscope. The substrates were cleaned *in situ* by a standard flashing procedure at 1473 K.¹⁷ Ge was deposited by physical-vapor deposition at 873 K at constant flux of $(1.8 \pm 0.2) \times 10^{-3}$ ML/s [1 monolayer (ML) corresponds to 6.3×10^{14} atoms/cm²]. The flux was calibrated from the increasing area of terraces between two successive STM images during the layer-by-layer growth.¹⁸

STM measurements were carried out at room temperature in the constant-current mode, using W-probe tips.

At a Ge coverage $\Theta_1 = (4.0 \pm 0.2)$ ML, the Si(1 1 10) surface exhibits a composite morphology where different structures coexist [Fig. 1(a)]. On a rough wetting layer (WL), {105}-faceted undulations are locally formed, resulting in an isolated unit (preripple) [Fig. 1(b)]. This preripple appears split in half along its long axis and resembles the subcritical nuclei on singular Si(001) surfaces, which precede the formation of full {105} pyramids.¹⁹ Adjacent {105} facets grow bottom up until they meet at the top of the preripple and, subsequently, extend laterally as the island elongates along the [110] direction [Fig. 1(c)]. Progressively, new {105} layers grow on the top of each other, producing the characteristic multilayered structure (ripple), depicted in Fig. 1(d). This structure is not symmetric, as evident from the enlarged views, shown in Figs. 1(e) and 1(f), which display the opposite ends of the island along the miscut direction. On one side [Fig. 1(e)], the ripple is not closed by any real facet but

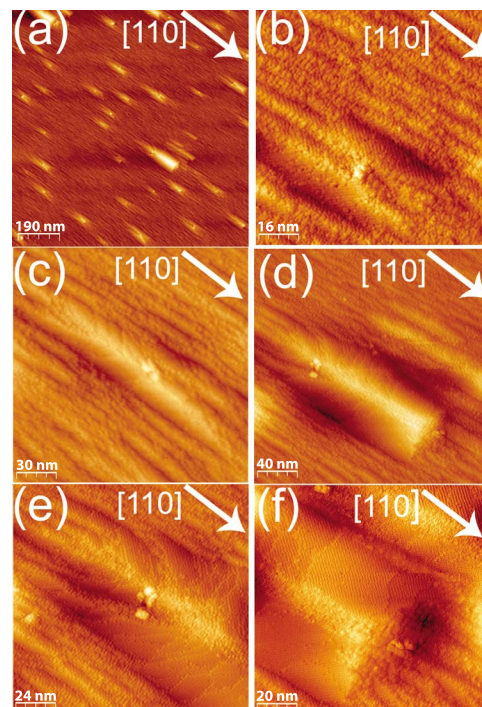


FIG. 1. (Color online) STM images of the Si(1 1 10) surface with a (4.0 ± 0.2) ML of Ge coverage.

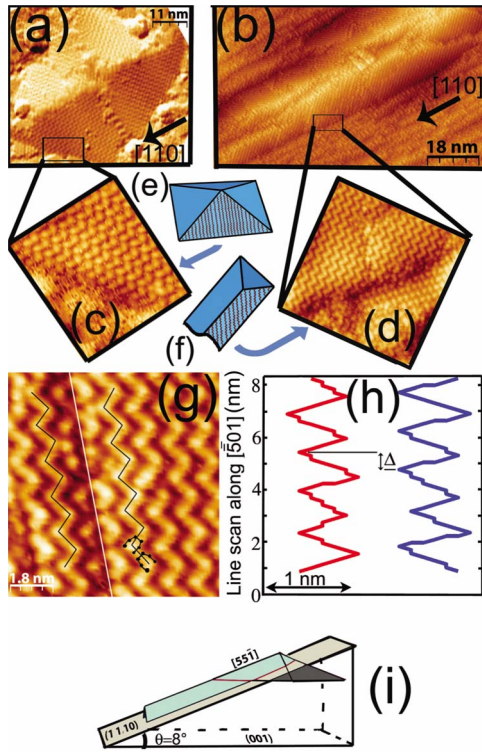


FIG. 2. (Color online) (a) STM image of a Ge pyramid on the flat Si(001) surface. (b) STM image of a ripple on the Si(1 1 10) surface. [(c) and (d)] Blow ups of the Ge(105) RS reconstruction near island edges: (c) pyramid and (d) ripple. [(e) and (f)] Schematics showing the orientation of the rows of the RS reconstruction for (e) pyramids and (f) ripples. (g) Filled-state STM image of a $[-501]$ step on the $\{105\}$ facet of a ripple ($V_s = -1.85$ V, $I = 0.85$ nA). The step is highlighted by a straight line and the row by a segmented line. The typical U-shaped structures of the RS reconstruction are superimposed onto the image. (h) Line profiles measured on panel (g). (i) Geometry of a ripple as resulting from cutting a $\{105\}$ pyramid with the (1 1 10) plane.

gradually lowers in height and width as the number of the stacked $\{105\}$ layers decreases near the end of the island. On the opposite side [Fig. 1(f)], the closure is sharper and consists of growing facets oriented approximately perpendicular to the miscut direction. The overall morphology can be easily imaged as the result of cutting a $\{105\}$ pyramid with a (1 1 10) plane along the $[110]$ direction, as schematically displayed in Fig. 2(i). Since the (1 1 10) plane is parallel to the $[55\bar{1}]$ intersection line of two adjacent facets of the pyramid, the down side of the ripple cannot be bounded by $\{105\}$ facets, confirming the experimental observations. On the Ge(105) surface, atoms form ordered arrays of U-shaped structures which are organized into zigzag rows orthogonal to the $[010]$ direction [rebonded-step (RS) reconstruction].^{20–22} This is the reason why, on the flat Si(001) surface, the $\{105\}$ -side facets of the pyramids are oriented along the $\langle 010 \rangle$ directions. Thus, the rows of the RS reconstruction are orthogonal to the pyramid edge [Figs. 2(a), 2(c), and 2(e)]. Since the vicinal (1 1 10) surface consists of arrays of (001) terraces separated by steps, in order to ensure a good matching to the WL, the rows must be kept orthogonal to the $[010]$ direction. As a consequence, they

form a 45° angle with the ripple edge, which is along the $[110]$ direction [Figs. 2(b), 2(d), and 2(f)]. It is worth noting that, due to their peculiar growth mode, most of the steps on the $\{105\}$ ripple facets run parallel to the rows (i.e., along the $[\bar{5}01]$ direction). A detailed analysis of these steps is still lacking, since most of the previous work was focused on the steps oriented along the $[010]$ direction, which are relevant on the flat surface.²¹ Therefore, we performed a systematic high-resolution STM study of such steps on the ripple facets. The typical configuration of a step is reported in Fig. 2(g). On the upper terrace [which is on the right-hand side of Fig. 2(g)], the RS reconstruction shows structural changes around the step edge. In particular, the outermost atoms of the U-shaped structures pointing toward the step edge are rearranged. We also find that steps are mostly bunched together. The height of a step can be easily measured since it is solely determined by the structural relationship between the upper and the lower terrace. Equivalent sites on the rows of the top and the bottom terraces are shifted along the $[\bar{5}01]$ direction by a quantity $\Delta = n s_x$ for a step of n monolayers ($s_x = 2.774$ Å; 1 ML = 0.55 Å).²¹ From the analysis of the row profiles in adjacent terraces, the most common configuration on adjacent terraces is a doubled-layer step, in which the rows are almost in antiphase [Figs. 2(g) and 2(h)].

So far, we have described the detailed structure of Ge ripples on the vicinal Si(1 1 10) surface. We now go on to show that, at the same coverage Θ_1 at which these ripplelike structures form, precursors of domes are present on the surface too. This is rather surprising, if compared with the growth on the flat surface, in which domes are formed at much higher coverage (>6 ML).¹⁰ The sample surface displays several different stages on the shape transition to domes, as shown in Figs. 3(a)–3(c). The morphological transformation starts with the local aggregation of ripples [Fig. 3(a)] and proceeds with the coalescence of the individual ripple units [Fig. 3(b)]. As the volume increases by aggregation and coalescence, the transition islands assume a rounded shape [Fig. 3(c)]. At this point, a further evolution is attained either by an annealing step at 993 K for 10 min [Fig. 3(d)] or by a slight increase in the Ge coverage up to $\Theta_2 = (4.8 \pm 0.2)$ ML [Fig. 3(e)]. The resulting morphologies are similar to each other and to the final dome shape. However, upon deposition of additional Ge, the evolution rate and the number of transitional islands is increased.

In the following, we model the essential features of the transition to domes on the vicinal surface with respect to the flat substrate. It is well known that, disregarding the edge contribution for a large island volume, the total-energy gain associated to the formation of a 3D island of volume V on the WL is

$$E_{tot} = e_{relax}V + e_{surf}V^{2/3}. \quad (1)$$

The first term represents the bulk strain relief and the second one accounts for the formation of island facets. The energy density of elastic relaxation, e_{relax} , is the (negative) difference between the residual strain energy stored in a Ge island of volume V and in the Si substrate after relaxation and the energy in an equivalent volume V of a fully strained epitaxial Ge film. The surface term, e_{surf} , is the extra surface

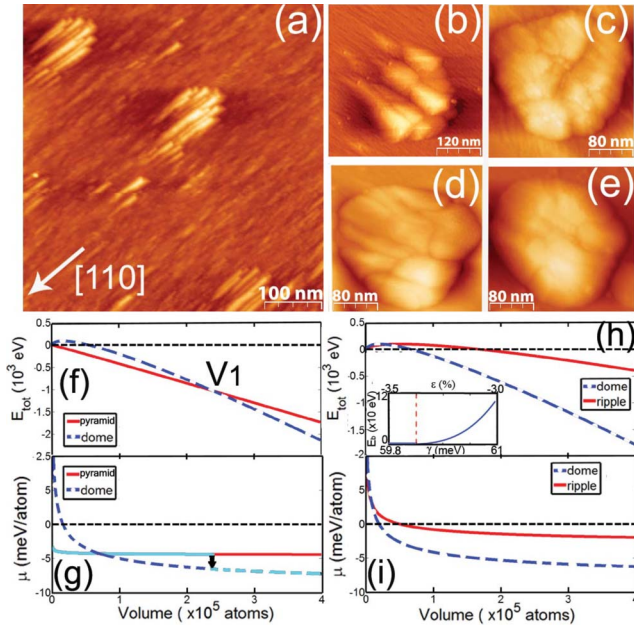


FIG. 3. (Color online) [(a)–(c)] STM images illustrating different stages of the transition to domes at (4.0 ± 0.2) ML of Ge coverage. Morphological modifications due to: (d) 10 min annealing at 993 K and (e) additional deposition of ~ 1 ML of Ge. [(f)–(i)] Thermodynamic stability of Ge islands on the flat and vicinal substrate. In all plots, WL is the reference zero energy. (f) Total energy vs volume for pyramids and domes on the flat surface and (g) the corresponding behavior of chemical potentials. The chemical potential corresponding to the lowest E_{tot} is indicated by the brighter color line showing a discontinuity at the critical volume V_1 marked by the arrow. (h) Total energy of ripples and domes on the Si(1 1 10) surface. In the inset the nucleation barrier E_b for ripple formation as a function of the strain is displayed. E_b corresponds to the maximum of the total energy vs strain curve, i.e., $\partial E_{tot}/\partial \epsilon = 0$. (i) Chemical potential for ripples and domes.

energy per unit area due to the presence of the island

$$e_{surf} = \left[\sum_{i=1}^N \gamma_i(\epsilon_i) S_i - \gamma_0 S_0 \right] V^{-2/3}, \quad (2)$$

where $\gamma_i(\epsilon_i)$ and S_i denote the surface energy and surface area of the i th facet of the island. S_0 is the base area of the island and γ_0 is the energy per unit area of the WL. In order to estimate E_{tot} , we treat the elastic term within the continuum elasticity theory, using finite-element method (FEM) calculations to evaluate the elastic energy relaxation. For the surface term, we use published density-functional theory (DFT) data for the surface energies, whenever available. For the flat Si(001) case, we set γ_0 to a value of $60.4 \text{ meV}/\text{\AA}^2$, corresponding to the energies of Ge/Si(001) with four layers of Ge,^{23,24} after subtracting the Ge/Si interfacial energy ($\approx 1 \text{ meV}/\text{\AA}^2$, see Ref. 25). The surface energy of the vicinal Si(1 1 10) surface, is estimated as $\gamma_0(\theta) = \gamma_0 \cos \theta + \beta \sin \theta$, where $\theta = 8^\circ$ is the miscut angle and β is the step formation energy per unit height.²⁶ Since the $\{105\}$ facets appear at the base of both pyramids and ripples and hence may be highly strained, we take into account the strain-dependent correction to the surface energies of these facets.

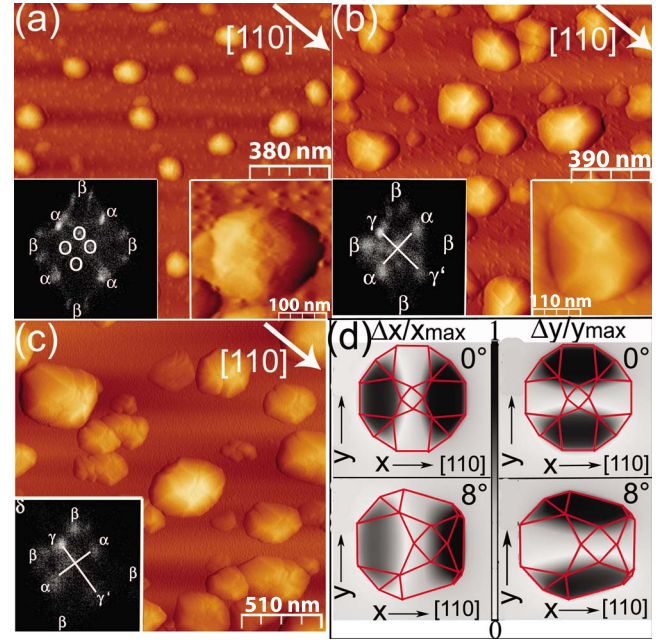


FIG. 4. (Color online) Morphology of domes at (7.0 ± 0.2) ML of Ge coverage: (a) on the flat Si(001), (b) on the vicinal Si(1 1 10), and (c) on the vicinal Si(118) surface. In the insets the corresponding surface orientation maps are shown. The spots of the various facets are labeled as follows: $\{105\}$ by \circ ; $\{113\}$ by α ; $\{15 \ 3 \ 23\}$ by β ; and $\{111\}$ by δ ; the new spots along the miscut direction on the vicinal surfaces are labeled by γ and γ' . (d) Relative displacement field calculated by FEM. Pictures in the first column show the component of the displacement field in the miscut direction; in the second column the orthogonal component of the displacement field is shown.

This is done by interpolating *ab initio* results for the dependence of the surface energy on strain²⁰ with the in-plane components of the strain averaged over each facet, taken from FEM calculations. The resulting surface energies are $59.8 \text{ meV}/\text{\AA}^2$ and $61.0 \text{ meV}/\text{\AA}^2$ for the $\{105\}$ facets on pyramids and ripples, respectively. The surface energy of some of the facets of the domes has not yet been assessed by DFT. However, a previous analysis shows that an average value of $65 \text{ meV}/\text{\AA}^2$ is a reasonable guess.²⁷ We verified that variations in the $61\text{--}69 \text{ meV}/\text{\AA}^2$ range do not alter our findings appreciably.

Figure 3(f) shows the dependence of E_{tot} vs V for pyramids and domes on the flat Si(001) surface. The island's chemical potential, μ , [Fig. 3(g)] is obtained by differentiating Eq. (1) with respect to the number of atoms (proportional to V).²⁸ The curves follow the usual morphological evolution of the system at the growth temperature.^{9,27} Pyramids are always more stable than WL, resulting in a barrierless island formation. The shape transition to domes is energetically favored for volumes larger than the critical value V_1 , where the energy curves cross. Moreover, it is a first-order transition since there is a discontinuity in μ (marked by an arrow) at the volume V_1 at which the two shapes are degenerate. In Figs. 3(h) and 3(i), we report analogous calculations for ripples and domes on the vicinal (1 1 10) surface. These calculations show that fully relaxed ripples have to overcome a small energy barrier. However, experiment indicates that

the {105} faceting develops continuously from the roughened WL without signs of a nucleation barrier [Fig. 1(b)]. Therefore, the initial steps of mound nucleation cannot be fully accounted for by the continuum approach [Eq. (1)] because it is based on two assumptions which are not fulfilled at the very early stages of island formation: (i) self-similar growth of the nanostructures and (ii) strain invariance during the growth. In fact at this stage elastic relaxation is not fully achieved. We find that for the high compressive misfit strain ($\varepsilon = -4.2\%$) and corresponding low surface energy $\gamma = 58.5 \text{ meV}/\text{\AA}^2$ of the {105} facets which the system experiences at the beginning of the nucleation stage, the barrier is absent, as shown in the inset of Fig. 3(h). By fully relaxing the misfit to $\varepsilon = -3.0\%$ (i.e., $\gamma = 61.0 \text{ meV}/\text{\AA}^2$) a nucleation barrier E_b develops. This is a quite general behavior due to the substantial energy gain associated to the {105} faceting under high compressive strain.^{2,21,29} Thus, the curve of the ripples describes correctly the full relaxation regime and indicates that this structure tends to convert into a more stable multifaceted dome, in line with the experiment. Nevertheless, kinetic considerations indicate that large multifaceted structures are unlikely to form directly from the WL. Our experimental observations suggest that ripples act as precursors of domes by collecting and piling up enough material into a dome shape [Fig. 3(a)]. This resembles what has been found on the flat Si(001) surface at $T > 675 \text{ }^\circ\text{C}$,²⁷ where stable domes arise from the fluctuations of metastable pyramids. Finally, we analyze the evolution of domes at large Ge coverage. Figure 4(b) shows the morphology of domes on the vicinal Si(1 1 10) surface, at a coverage of $(7.0 \pm 0.2) \text{ ML}$. The corresponding surface orientation map³⁰ reveals that domes are “topologically asymmetric.” In

comparison with the domes on the flat surface, which have two symmetric {113} facets along the [110] direction, the domes on the vicinal surface display different facets on the opposite sides. The same morphology is observed on the Si(118) surface {(001) substrate misoriented $\approx 10^\circ$ in the [110] direction} [Fig. 4(c)], indicating that the asymmetry is an intrinsic feature of domes nucleated on highly misoriented substrates. Recently, Spencer and Tersoff²⁶ have theoretically predicted that asymmetric Ge island shapes would occur on Si(001) at large miscut angles. Our experimental data confirm their findings. Moreover, our FEM calculations, made on 3D islands, show that the anisotropic shapes reflect the anisotropy of the elastic displacement field along the miscut direction. In Fig. 4(d), we report the relative displacement of domes along the miscut direction, x , and in the orthogonal direction. It can be seen that the displacement field is isotropic on the flat surface and anisotropic on the 8° -miscut substrate.

In summary, we have shown that the morphological evolution of Ge on vicinal Si(1 1 10) differs markedly from the usual path on the flat (001) surface. At the beginning of the growth, the stabilization of the Ge{105} surface under high compressive strain leads to the barrierless formation of rippled structures. After full elastic relaxation, ripples become unstable with respect to the formation of multifaceted domes. In contrast to what happens on singular surfaces, the formation of domes is accomplished by coalescence of several ripple units.

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